



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG797677252
Report verification at igi.org

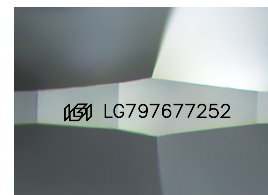
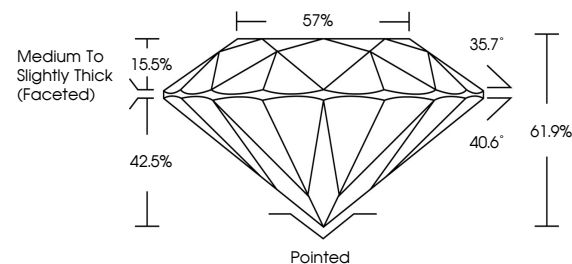
May 14, 2026	
IGI Report Number	LG797677252
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	7.94 - 7.99 X 4.94 MM
GRADING RESULTS	
Carat Weight	1.93 CARAT
Color Grade	E
Clarity Grade	VVS 2
Cut Grade	IDEAL

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG797677252

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

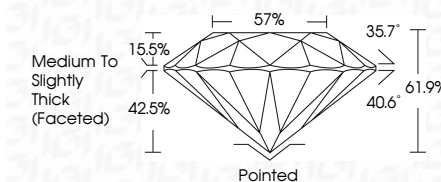
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

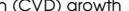
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www.igi.org

May 14, 2008	Carat Weight	1.00 CARAT
Report No: LG97677282	Color Grade	E
ROUND BRILLIANT	Clarity Grade	VVS 2
5.94 - 7.99 X 4.94 MM	Cut Grade	IDEAL
	Depth	61.9%
	Table	57%
	Medium To Slightly Thick (rounded)	
	Color	Pointed
	Polish	EXCELLENT
	Symmetry	EXCELLENT
	Fluorescence	NONE
	Inscriptions(s)	169 LG97677282
	Comments:	
		The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
		Type IIA